## UNITED STATES PATENT AND TRADEMARK OFFICE



Commissioner for Patents United States Patent and Trademark Office P.O. Box 1450 Alexandria, VA 22313-1450 www.uspto.gov

Mailed:

JAN 2 6 2005

wak Paper No.

**DECISION ON** 

**PETITION** 

In re application of Ting-Chang Chang et al. Serial No. 09/681,986

Filed: July 03, 2001

For: N

METHOD OF AVOIDING DIELECTRIC LAYER

DETERIORATION WITH A LOW DIELECTRIC CONSTANT DURING A STRIPPING PROCESS

This is a decision on a PETITION TO WITHDRAW HOLDING OF ABANDONMENT, originally filed June 1, 2004.

## **DECISION**

The application became abandoned on 3/28/2003 for failure to pay the issue fee in response to a Notice of Allowance mailed on 11/20/2002. The Examiner in the Notice of Allowability marked the box indicating the new drawings including changes required by the PTO-948 were to be submitted and that the relevant PTO-948 sheet was attached. However applicant never received that sheet. Applicant had an interview with the examiner on 1/23/2003 to request a copy of PTO-948 be sent to applicant. The examiner responded that a former request forth PTO-948 must be submitted. Applicant complied with this request on 1/29/2003. Applicant has received no response to this request nor was the notice of Abandonment was ever received.

Therefore, the Petition is **GRANTED**.

The abandonment is withdrawn and a new notice of allowance along with a copy of the PTO-948 will be mailed to the applicant.

Jacqueline Stone, Director Technology Center 1700 Chemical and Materials Engineering

Winston Hsu NAIPC P.O. Box 506 Merrifield, VA 22116

notire